



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of

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Young-Goo Lee : Group Art Unit 2822

Serial No. 10/029,147 : Examiner Maria F. Guerrero

Filed December 28, 2001

METHOD OF FABRICATING SEMICONDUCTOR DEVICE FOR PREVENTING CONTAMINATING PARTICLE GENERATION

AMENDMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, **Mail Stop Amendment** Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

In response to the Office Action of October 15, 2004, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.